



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant | : Paul B. Mirkarimi et al. | Docket No. | : CIL-10972 |
| Serial No. | : 10/086,614 | Art Unit | : 1762 |
| Filed | : March 1, 2002 | Examiner | : W. Markham |
| For | : Ion-Assisted Deposition Techniques For The Planarization Of Topological Defects | | |

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Non-Compliant Amendment mailed November 8, 2006 and the Office Action mailed February 16, 2005, please amend the above-referenced application as follows: